

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kobayashi, Migaku

Serial No.: 10/060,569

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Title: METHOD OF FABRICATING A  
SEMICONDUCTOR DEVICE

Attorney Docket No.: N230500C1

Group Art Unit: 1763

Examiner: Goudreau, George A.

#8

10/29/02  
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## RESPONSE TO OFFICE ACTION

5 Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

10 The following is submitted in response to the Office Action dated July 31, 2002, and is  
currently due October 31, 2002.OFFICIAL  
FAX RECEIVED  
OCT 29 2002  
GROUP 170037 C.F.R. §1.8

I hereby certify that this correspondence is being

30 [X] transmitted via facsimile to the United States Patent and Trademark Office to fax number: 1-703-872-9310  
Date of Transmittal: October 28, 200235 [ ] deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for  
Patents, Washington, D.C. 20231.

Date of Deposit: \_\_\_\_\_

40 Typed/Printed Name: Bradley T. SakoSignature: [Signature]